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** CONTINUING DATA ***** *none y/h*** FOREIGN APPLICATIONS ***** *yes y/h*

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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>7/23/01</i>				
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials				

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TITLE

Method for fabricating semiconductor device including annealing an electrode in a reducing atmosphere before capacitor insulating film forming

FILING FEE RECEIVED 1242	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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